



14701

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OKU et al

Serial No.: 09/903,764

Filed: July 13, 2001

For: FILM FORMING METHOD, SEMICONDUCTOR
DEVICE AND SEMICONDUCTOR DEVICE MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 (b)(1)

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

It is respectfully requested that the examiner consider and cite of record the three references listed on the attached, copies of which are submitted herewith.

Respectfully submitted,

George A. Loud
Reg. No. 25,814

Dated: July 24, 2001

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